



500.39750VX1

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: OHMOTO et al

Serial No.: 10/663,646

Filed: September 17, 2003

For: Plasma Processing Apparatus

Art Unit: 1763

Examiner: R. Dhingra

AMENDMENT

Mail Stop: Amendment (Fee)
Commissioner For Patents
P.O. Box 1450
Alexandria, VA 22313-1450

May 9, 2006

Sir:

The following amendments and remarks are respectfully submitted in connection with the accompanying RCE of the above-identified application, in response to the Office Action dated February 14, 2006. The amendments are listed below and set forth on the following pages.

Amendments to the Claims; and

Remarks are included following the amendments.